

**Notice of References Cited**

Application/Control No.

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Applicant(s)/Patent Under

Reexamination

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Examiner

Samuel G. Neway

Art Unit

2626

Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-4,574,362	03-1986	Spindel et al.	710/65
*	C	US-7,013,422	03-2006	McCarley et al.	714/794
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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